

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0.

<b>Title of Invention</b>	<b>METHOD FOR DEEP TRENCH ETCHING THROUGH A BURIED INSULATOR LAYER</b>										
<p>Application Number : Confirmation Number: First Named Applicant: Herbert Ho Attorney Docket Number: FIS920030214US1 Art Unit: Examiner: Search string: ( 5914280 or 6479394 or 6518192 or 20010001719 or 20020192969 ).pn</p>											
<b>US Patent Documents</b>											
<b>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</b>											
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass				
EC	1	5914280	1999-06-22	Gelzinis							
J	2	6479394	2002-11-12	Choutov, et al.							
J	3	6518192	2003-02-11	Khan, et al.							
<b>US Published Applications</b>											
<b>Note: Applicant is not required to submit a paper copy of cited US Published Applications</b>											
init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass				
EC	1	20010001719	2001-05-24	Haakey, et al.							
J	2	20020192969	2002-12-19	Losee							
<p><b>Signature</b> <i>Eve Chen</i> <i>1/26/05</i></p> <table border="1"><tr><td>Examiner Name</td><td>Date</td></tr><tr><td></td><td></td></tr></table>								Examiner Name	Date		
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